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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Tomoko TAKAGI et al.

Date: January 25, 2006

Serial No.: 10/726,300

Group Art Unit: 1753

Filed: December 1, 2003

Examiner: ---

For: THIN FILM DEPOSITING METHOD AND APPARATUS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art, together with a form listing the same for the convenience of the Examiner. A translation of the Office Action has been provided in lieu of a Statement of Relevancy of the present invention to the teachings of the teachings of the cited prior art.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 25, 2006

Max Moskowitz

Name of applicant, assignee or  
Registered Representative

Signature

January 25, 2006

Date of Signature

Respectfully submitted,

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